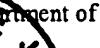


INFORMATION DISCLOSURE STATEMENT BY APPLICANT
(Use several sheets if necessary)

 U.S. Department of Commerce, Patent and Trademark Office <i>MAY 05 2004</i> <i>JCB1</i> <i>INTERFACILITY MAIL</i> INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)	Application No.:	10/016,943
	Filing Date:	December 13, 2001
	First Named Inventor:	Pablo I. Rovira
	Group Art Unit:	2877
	Examiner Name:	Samuel A. Turner
	Confirmation No.:	7400
	Attorney Docket No.:	NAN051 US

U.S. Patent Documents

Foreign Patent Documents

Other Art (Including Author, Title, Date, Pertinent Pages, Etc.)

SAT	3.	F. Abeles, "Methods for Determining Optical Parameters of Thin Films" in <i>Progress in Optics</i> , Vol. II, E. Wolf, Ed. (North Holland Publishing, Amsterdam, 1963), pp. 248-288

Examiner: <u>S.A. Tunner</u>	Date Considered: <u>7-27-04</u>
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* Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication with applicant.